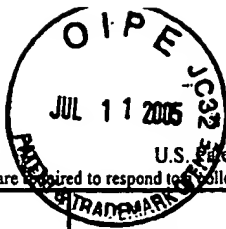


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PTO/SB/08A (08-00)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	09/986,743
		Filing Date	November 9, 2001
		First Named Inventor	Shunpei YAMAZAKI et al.
		Group Art Unit	2812
		Examiner Name	A. Ghyka
		Attorney Docket Number	0756-2378
Sheet	1	of	1

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Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
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		Office ²	Number ²	Kind Code ² (if known)			
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
Ae		Office Action dated April 8, 2005 from Patent Office of the People's Republic of China, for Application No. 00122783.1.	
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Examiner Signature		Date Considered	7/27/05
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